

**Notice of References Cited**

Application/Control No.

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Applicant(s)/Patent Under

Reexamination  
KIM, HONG KOO

Examiner

Marcos D. Pizarro-Crespo

Art Unit

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Richard C. Jaeger; Volume V Introduction to Microelectronic Fabrication; Addison-Wesley Publishing Company; Reading, Massachusetts, 1993, pp.41-42
	V	
	W	
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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